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SERIAL NUMBER 10/811,152	FILING OR 371(c) DATE 03/29/2004 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. 123034-05004767
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## APPLICANTS

Ga Won Lee, Kyungki-Do, KOREA, REPUBLIC OF;

## \*\* CONTINUING DATA \*\*\*\*\*

This application is a DIV of 10/028,972 12/28/2001 ABN MA

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

REPUBLIC OF KOREA 2001-36731 06/26/2001 MA

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 06/10/2004

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 6	TOTAL CLAIMS 4	INDEPENDENT CLAIMS 2
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature <i>M. Ahmad</i>	Initials <i>MA</i>			

## ADDRESS

43569

## TITLE

Method of forming inter-dielectric layer in semiconductor device

FILING FEE RECEIVED 770	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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